

EL169867036

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IDS
5/18/00
A. Yuku

Inventor: Chris Parfeniuk et. al.

Title: Methods of Bonding First and Second Masses to One Another, and
Methods of Bonding Physical Vapor Deposition Target Materials to
Backing Plate Materials

Assignee: Honeywell International, Inc.

JC678 U.S. PTO
09/488973
01/20/00

INFORMATION DISCLOSURE STATEMENT

PURSUANT TO 37 C.F.R. §§1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§1.56, 1.97 and 1.98, your attention is
directed to the United States patents and other references listed on the
attached Form PTO-1449.

The listed references were cited by, or submitted to, the Office in the
parent, co-pending application of the above-identified application. The above-
identified application is a continuation of co-pending application Serial No.
09/057,152 filed April 7, 1998. Such prior disclosure is sufficient for the
above-identified application as far as copies of the references are concerned.
37 C.F.R. §1.98(d) and MPEP §609(2). No admission is made regarding
whether all the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

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3 Dated: 1/26/00

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6 Dated: 01/14/00

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8 Dated: 1-12-00

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